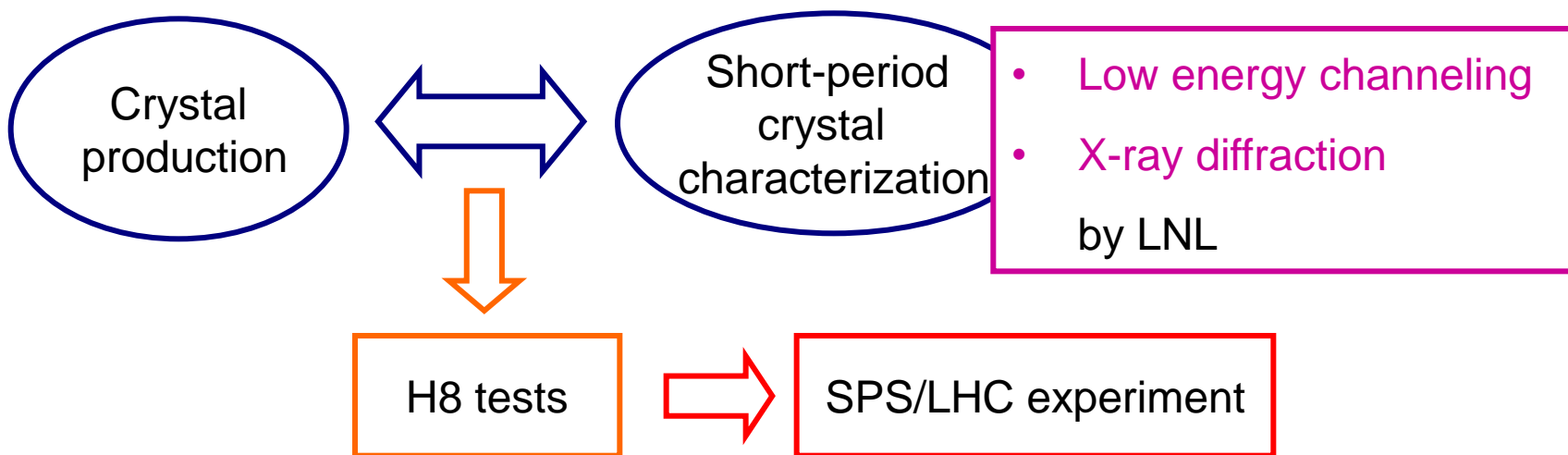


Low energy channeling and x-ray diffraction for crystals characterization

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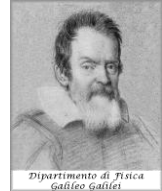
Introduction

- Different kinds of crystals for collimation applications have been produced by Ferrara group.
- The fundamental tests on such crystals have been performed in H8 experimental area.
- Crystal production optimization need a short period feedback basically provided by LNL group.



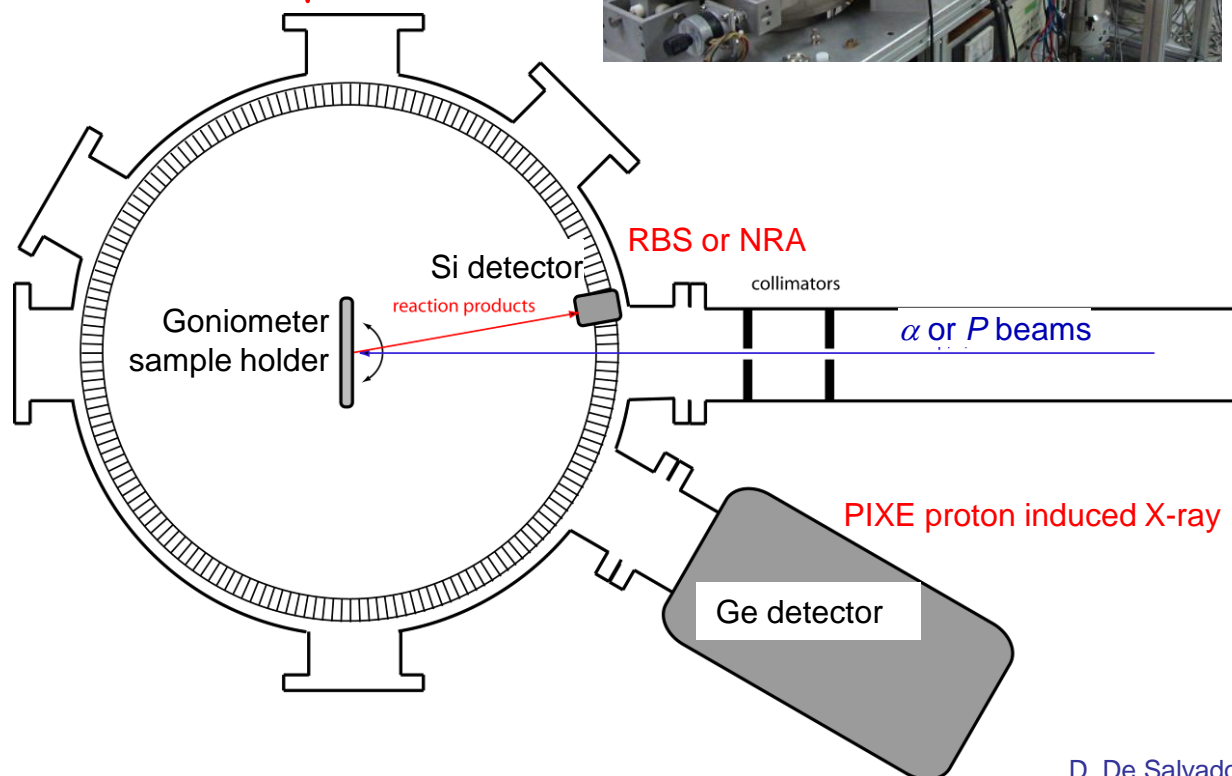
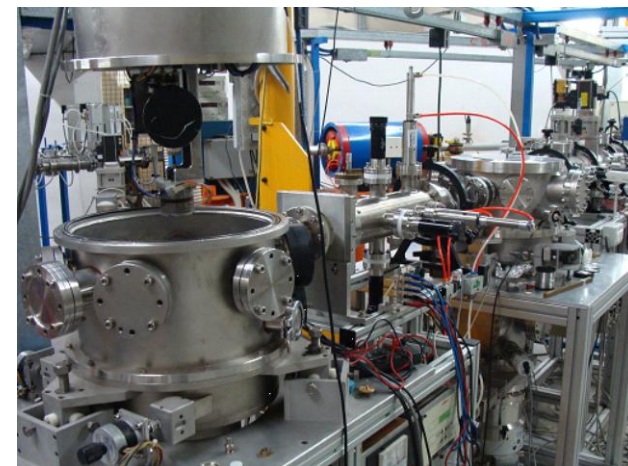
AIM: to describe the use of the two techniques for the UA9 crystal characterization

Low energy channeling apparatus

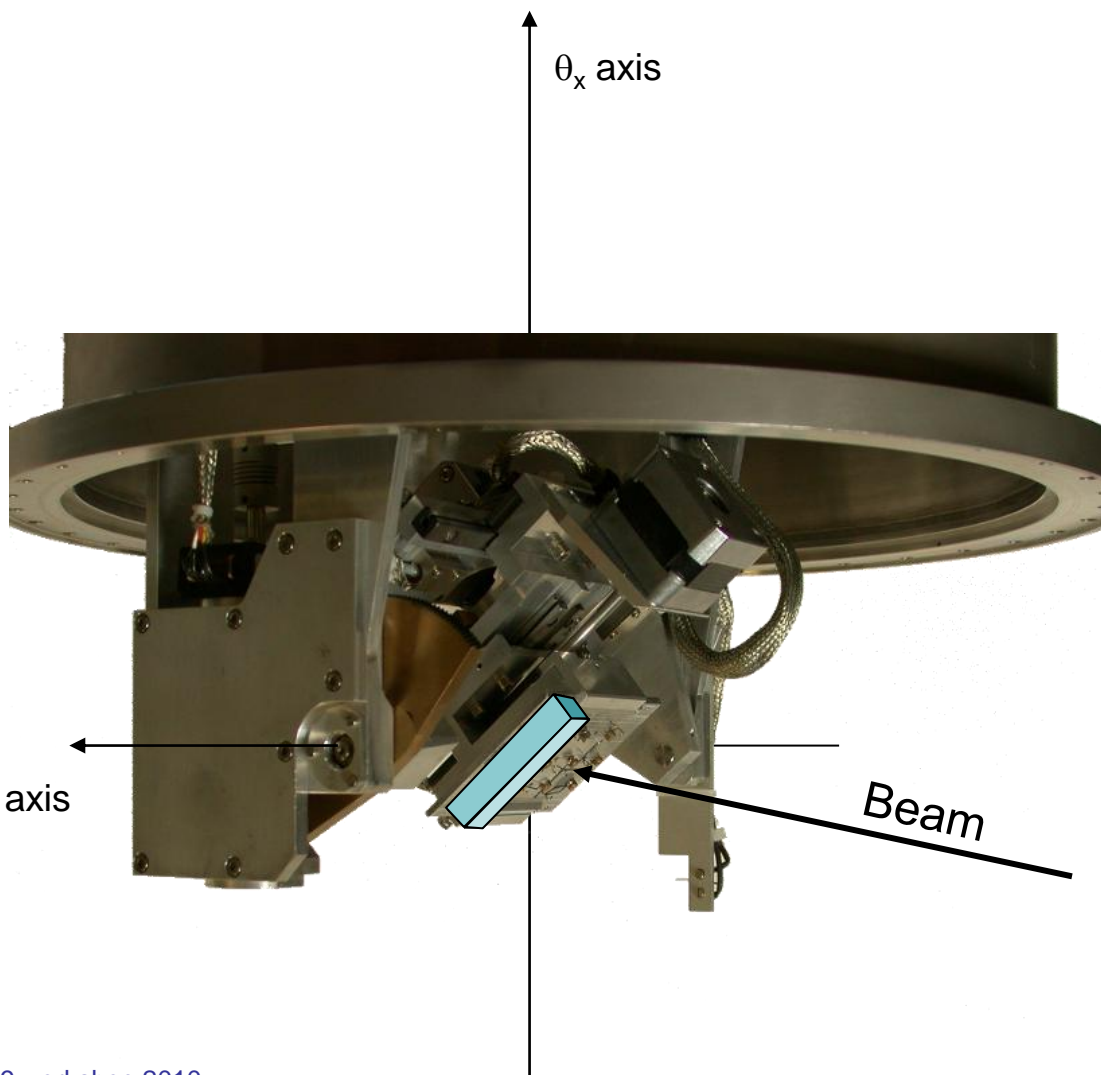


LNL open facility - about monthly available by application

- α or P beams
- Energies : 2 to 7 MeV
- Investigated depth in Si: 0.5 to 60 μm



The goniometer for low energy channeling studies



Ang. Resolution = 0.2 mrad
Beam divergence < 0.3 mrad

but

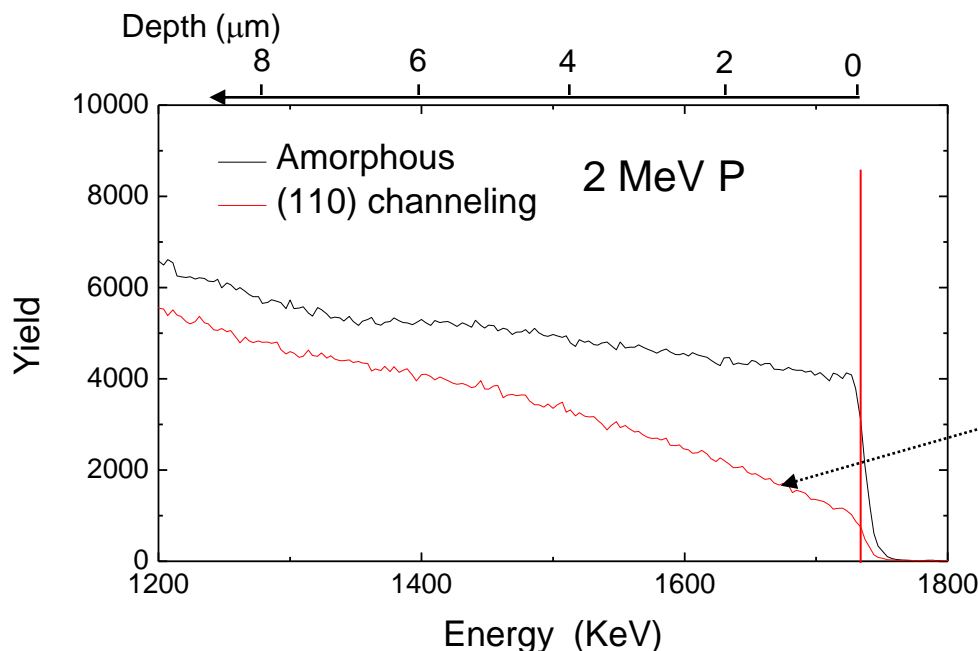
Typical critical angle 2 mrad

Translation resolution 0.01 mm
Beam size down to 0.2 mm

suited

for analysis on the strip
border where channelling
beam impinges

What can we learn ?



In channeling condition only
the non-channeled particles
undergo backscattering



Channeling inefficiency can
be measured in the surface
region

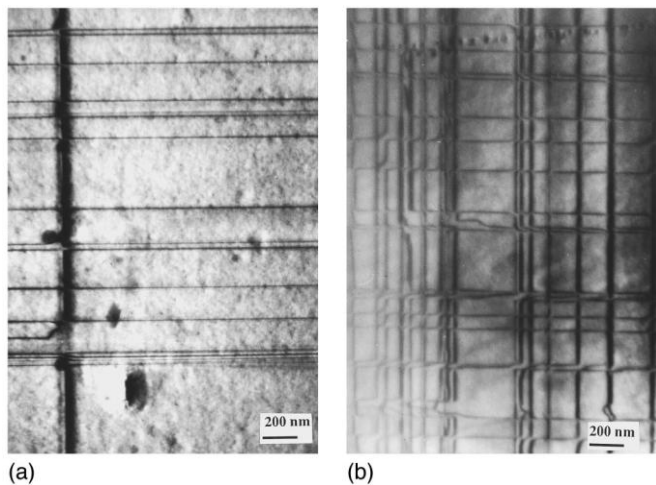
Low energy efficiency is related to nuclear and electronic
dechanneling and, if present, by **defect-related** dechanneling.



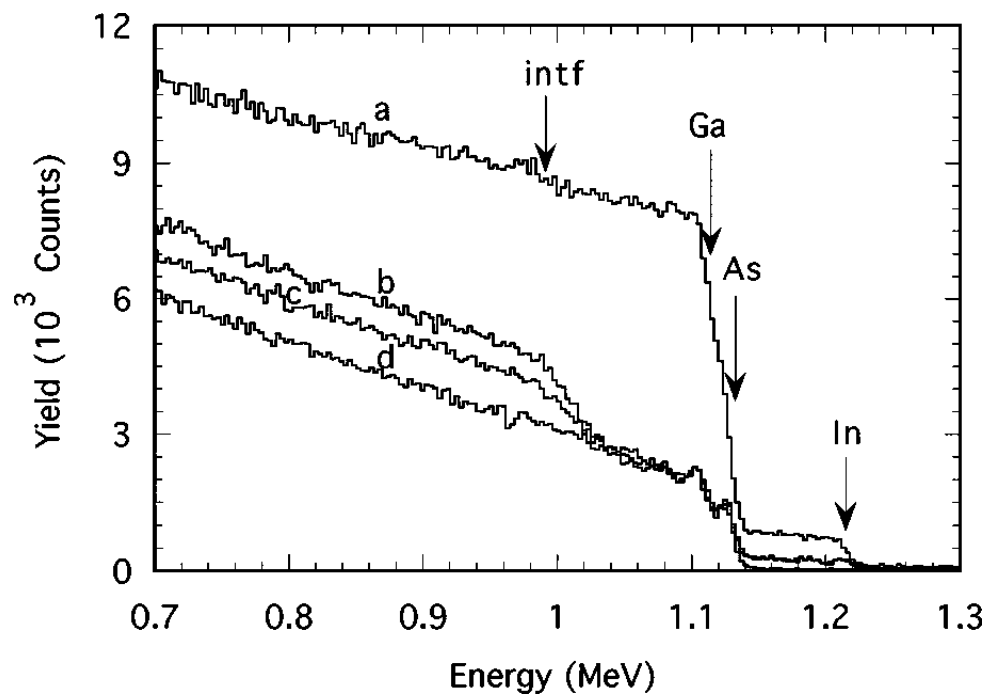
good test for sample preparation quality

Dechanneling by dislocations

Single layer $\text{In}_x\text{Ga}_{1-x}\text{As}/\text{GaAs}$ strained structure
TEM images

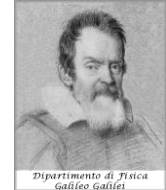


Single layer $\text{In}_x\text{Ga}_{1-x}\text{As}/\text{GaAs}$ strained structure
(110) and (1-10) planar channeling

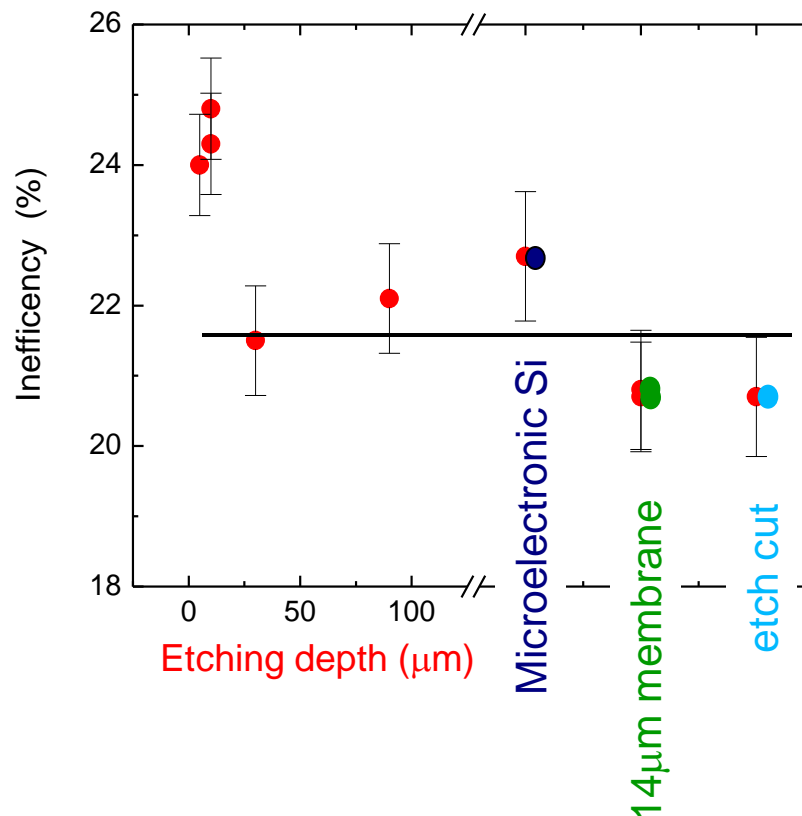


Mazzer, Drigo, Romanato, Salviati and Lazzarini PRB 56, 6895, 1997

(110) 2 MeV P in-efficiency



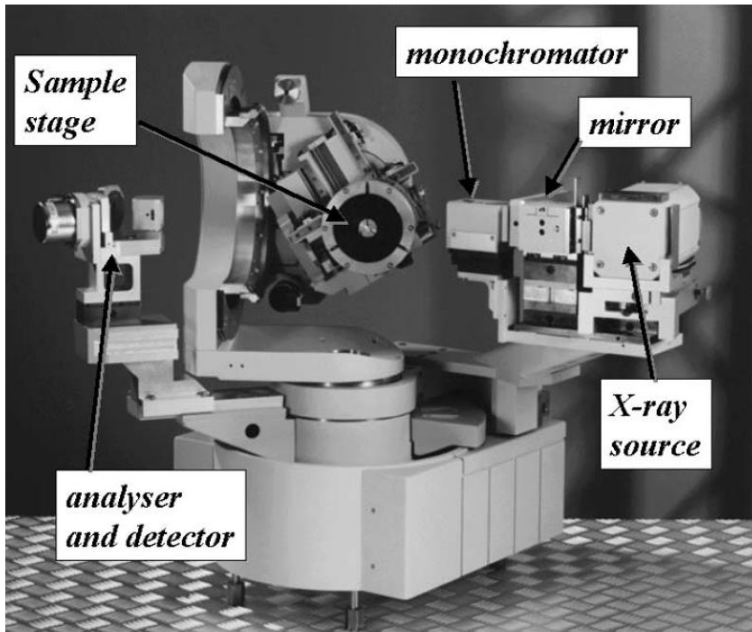
- Strips crystal **mechanical dicing + isotropic etching** (as ST21, ST38A & ST40A); etching depth was optimized
- Anisotropic **etch cut** strips (as ST45A)
- Thin **membrane** for H8 focusing experiment



High Resolution X-ray Diffraction



Internal facilities @ University of Padova physics department (about weekly available)



Accurate analysis of Bragg reflection from crystalline planes:

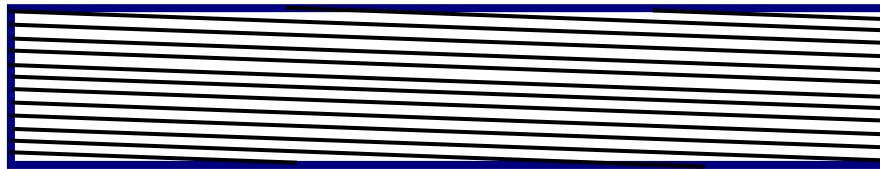
- 5 angular axis (4 for the sample 1 for detector)
- Finest movement resolution: 2 μrad
- 3 translations (1 to 10 μm resolution)
- 8 KeV X-rays with 30 μrad divergence and 30 μrad acceptance.
- Investigated depth in Si about 50 μm

What can we learn from HRXRD ?



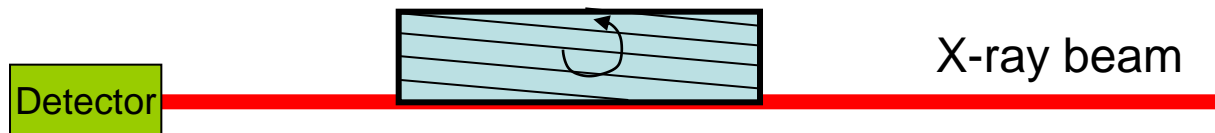
- Orientation of lattice planes
- Deformation of lattice planes

The sign and the amount of the miscut are important for channeling performances.



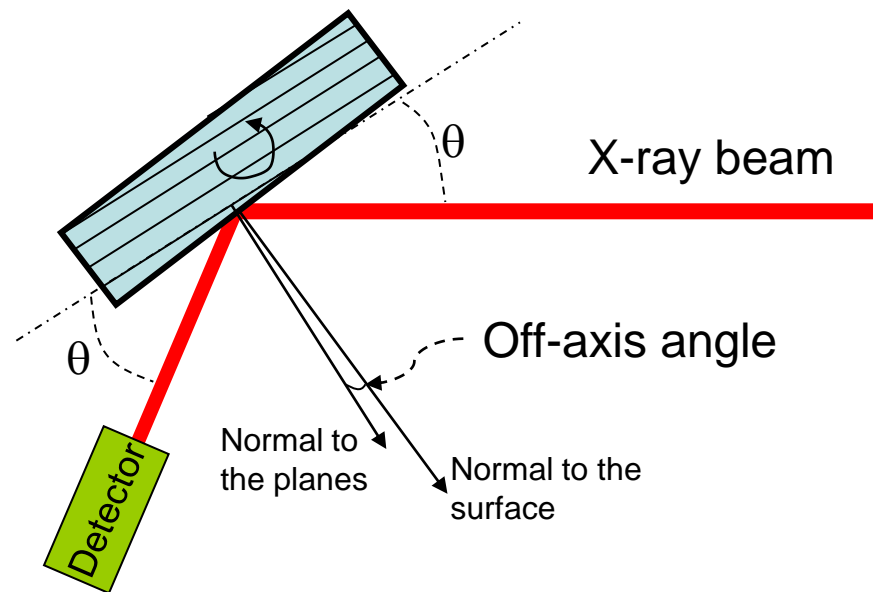
Off-axis measurement - 1

Direct beam: characterization of the surface orientation



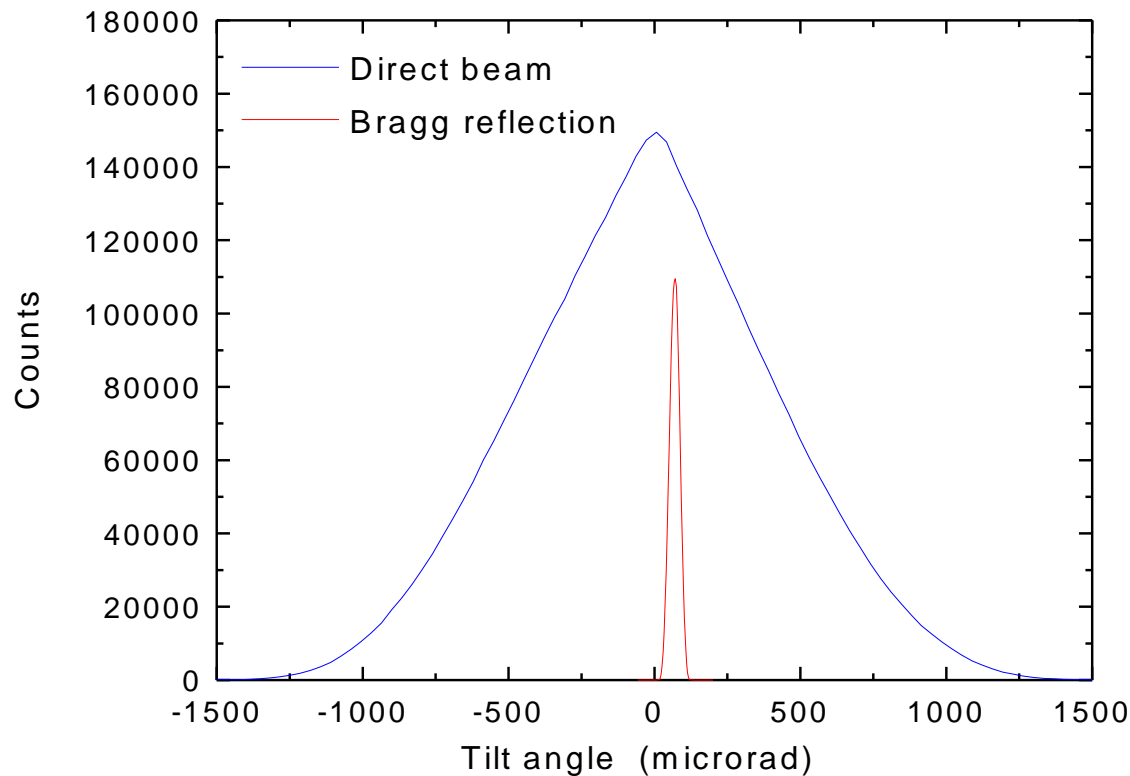
Maximum signal when the surface is parallel to the beam (zero correction)

Bragg reflection: Signal from a bragg plane reflection occurs only when the sample is rotated by the miscut angle



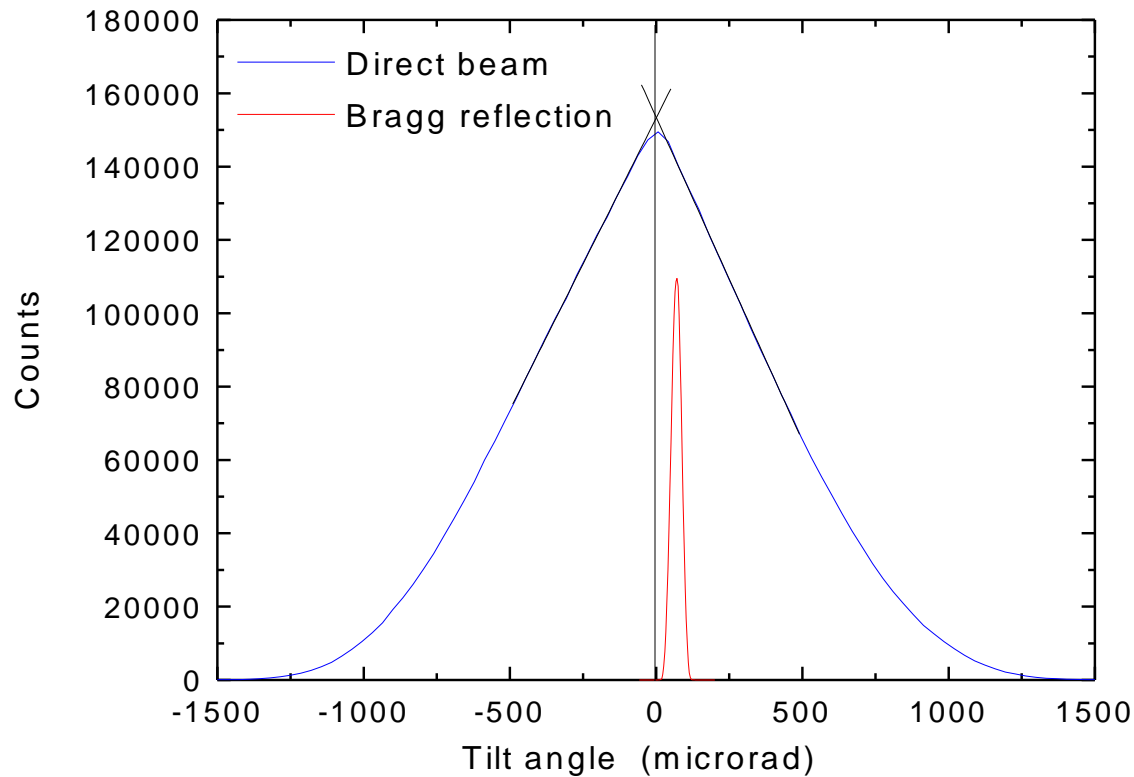
Off-axis measurement example

Off-axis : $70 \pm 30 \mu\text{rad}$



Off-axis measurement example

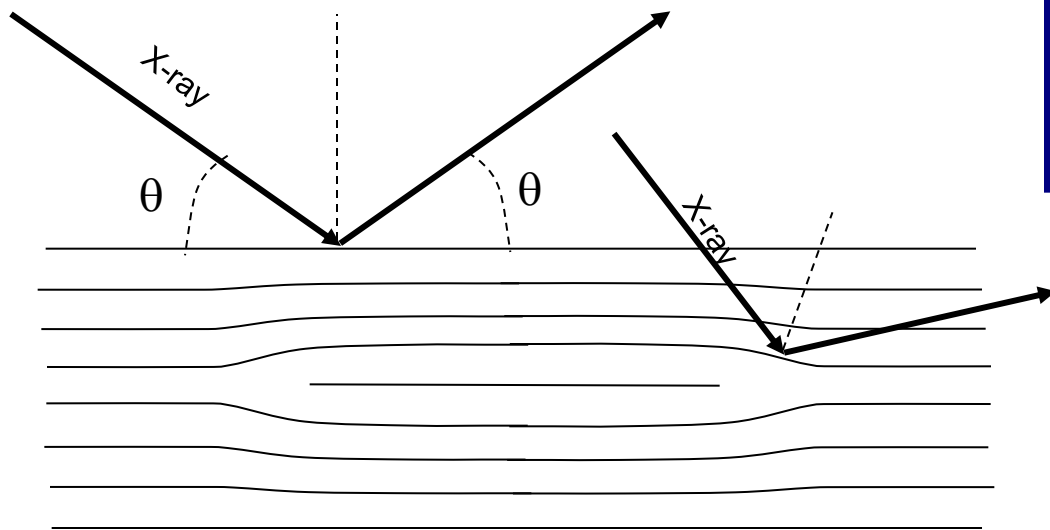
Off-axis : $70 \pm 30 \mu\text{rad}$



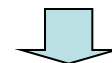
What can we learn from HRXRD ?

- Orientation of lattice planes
- Deformation of lattice planes

Crystal defects (dislocations, cracks etc.) cause strong lattice deformation in a confined zone of the crystal

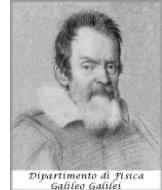


A small part of the scattered X-rays occurs at a different incidence angle



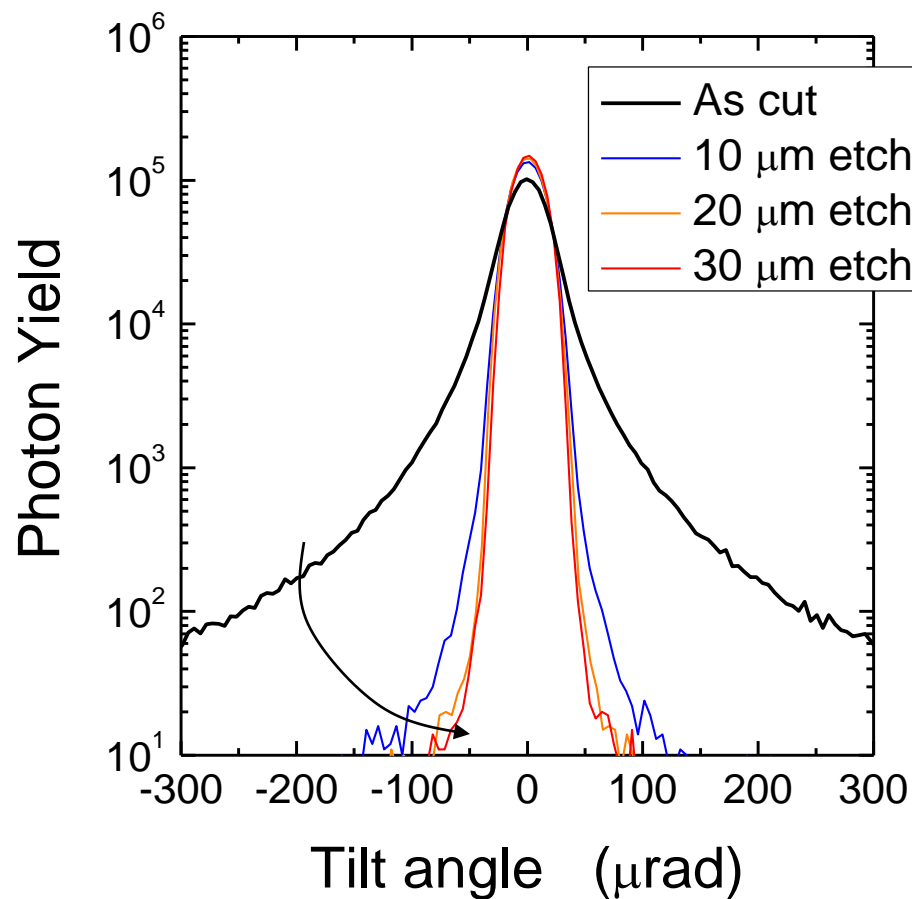
Diffuse scattering tails

Dicing & isotropic etching

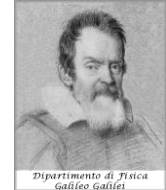


Crystals with mechanical
dicing + isotropic etching

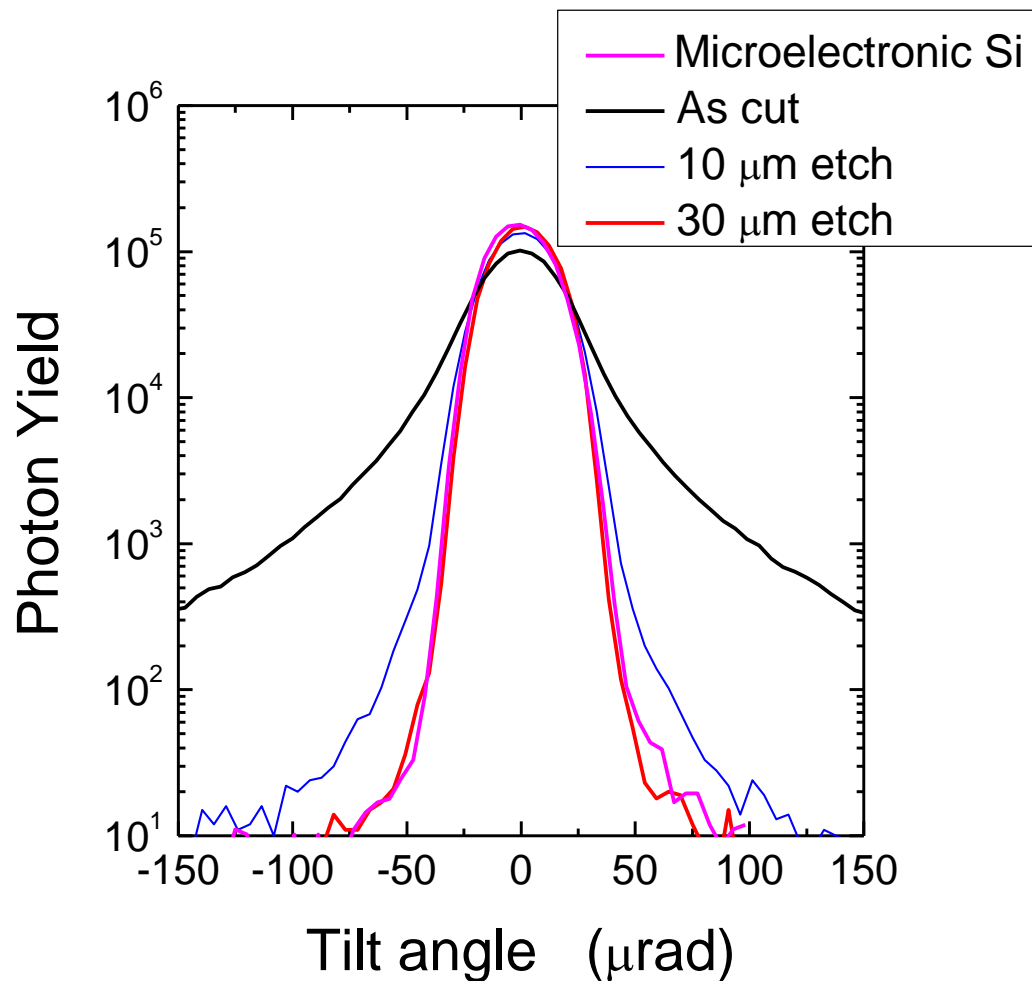
Diffuse scattering reduces
of order of magnitudes with
etching



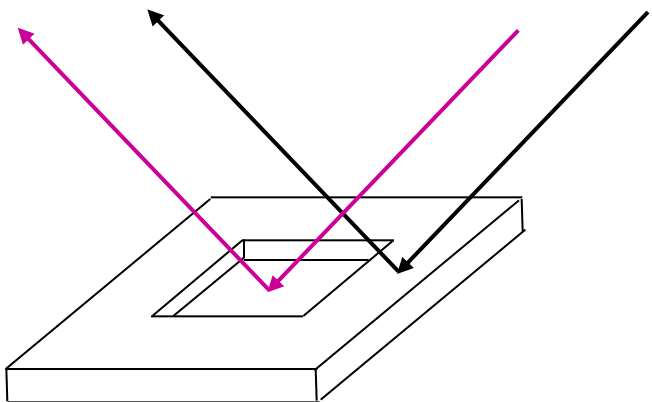
Measurements on recent process



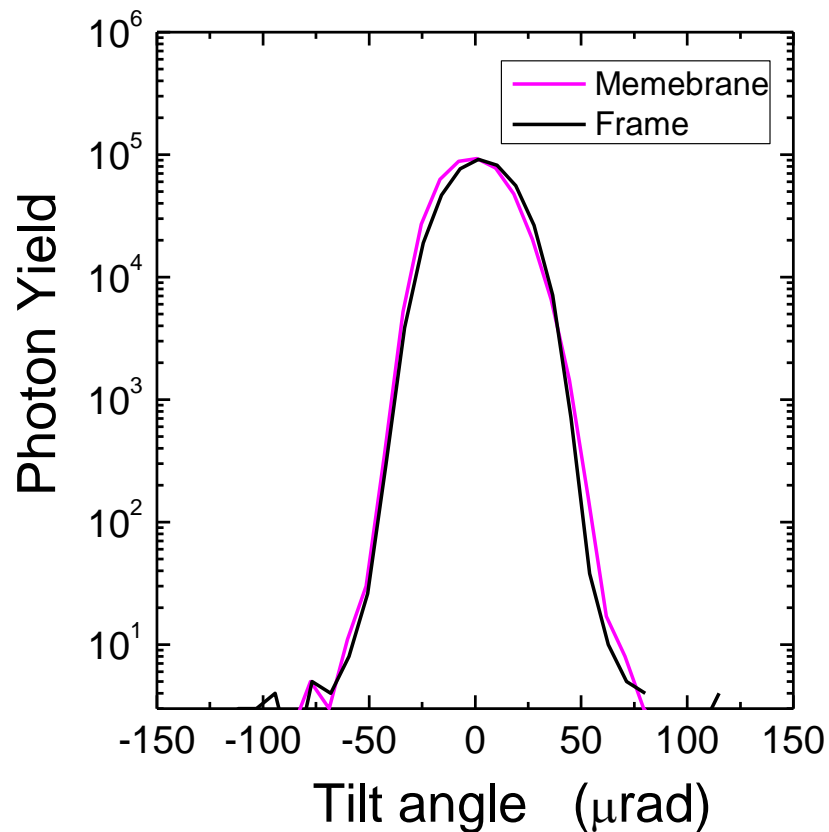
Scattering fingerprint is the same as for a microelectronic grade Si.



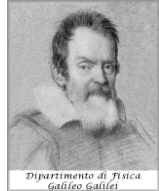
Membrane sample



The frame (that is a microelectronic grade Si surface) and the membrane have the same crystalline quality



Conclusions



- Low energy channeling is an effective test frame for optimizing sample preparation
- High resolution X-ray diffraction gives access to off-axis evaluation and confirms in more detail the crystalline quality
- Very high standard of preparation for the recent samples is demonstrated

Channeling comparison

